

Figure 1

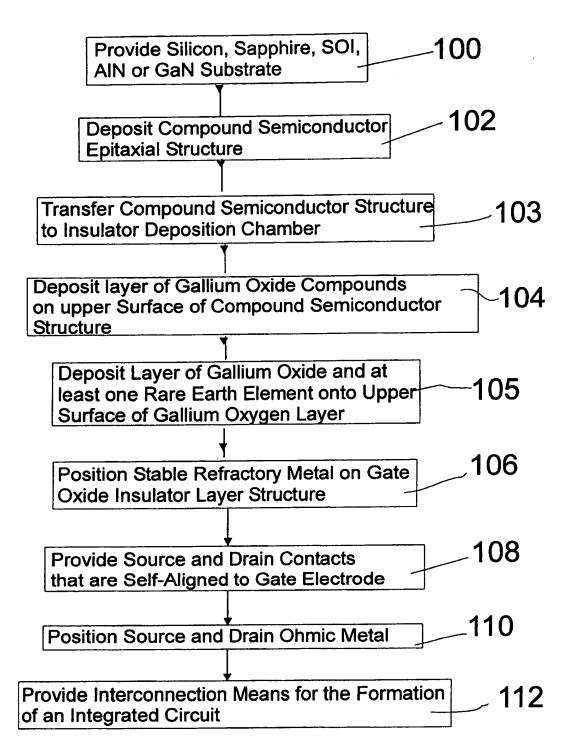


Figure 2

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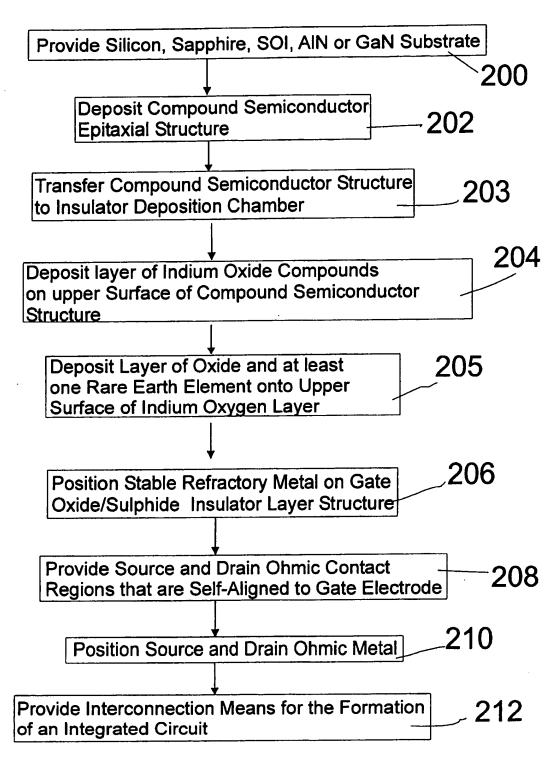


Figure 3

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Layer	Thickness	Doping	Description	Comment
6	120	-	Gate-Oxide	
5	4	<u>-</u>	GaN	
4	300	n=1E18	AlGaN	x=0.20
3	500	n=2E17	InGaN	x=0.03
2	8000	-	GaN	buffer
1	500	-	AlN	buffer

Figure 4

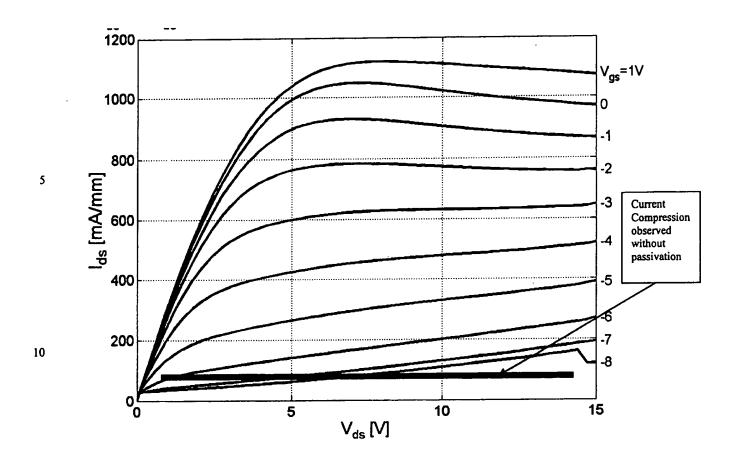


Figure 5

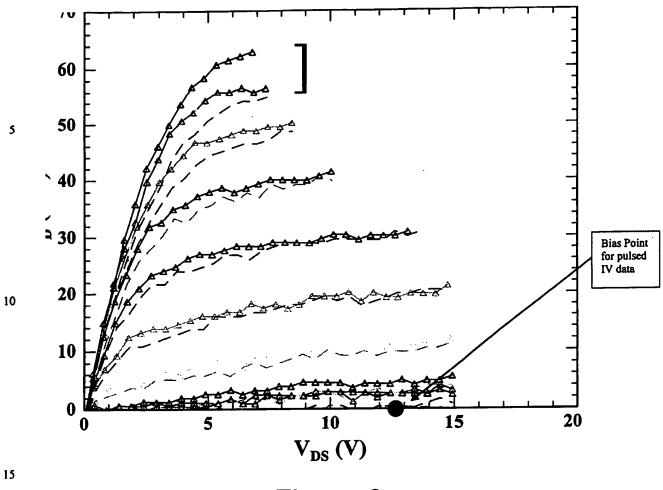


Figure 6

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Layer	Thickness	Doping	Description	Comment
6	120	-	Gate-Oxide	
5	40	d-doped	AIN	
4	200	n=1E18	AlGaN	x=0.90
3	5000	-	AIN	buffer
2	<500	-	AIN	Nucleation layer
1		-	AIN	substrate

Figure 7